

Commissioner for Patents United States Patent and Trademark Office P. O. Box 1450 Alexandria, VA 22313-1450

COPY MAILED

MOSER, PATTERSON & SHERIDAN, LLP/ APPLIED MATERIALS, INC. 3040 POST OAK BOULEVARD, SUTIE 1500 HOUSTON TX 77056

FEB 1 1 2005

OFFICE OF PETITIONS

In re Application of

Yoichi Suzuki, et al.

Application No. 10/004,489

ON PETITION

Filed: October 23, 2001

Attorney Docket No. SOEI/0011

This is a decision on the petition under 37 CFR 1.313(c)(3), filed by facsimile transmission on February 10, 2005, to withdraw the above-identified application from issue after payment of the issue fee.

Petitioner requests that the application be withdrawn from issue for express abandonment. See 37 CFR 1.313(c)(3).

The petition is GRANTED.

The application is hereby withdrawn from issue, and the abandonment is hereby recognized.

Telephone inquiries should be directed to the undersigned at (571) 272-3204.

The application is being referred to the Office of Publications to be processed as an abandoned file.

Sherry D. Brinkley Petitions Examiner Office of Petitions

Office of the Deputy Commissioner for Patent Examination Policy



Commissioner for Patents United States Patent and Trademark Office P. O. Box 1450 Alexandria, VA 22313-1450 www. uspto. gov

Date

February 11, 2005

TO

: Director, Office of Patent Publication

FROM

: Office of the Deputy Commissioner

for Patent Examination Policy

SUBJECT

: Withdrawal from Issue of

Applicant(s)

: Yoichi Suzuki, et al.

Application No.

: 10/004,489

Filed

: October 23, 2001

The above-identified application has been assigned Patent No. 6,855,644 and an issue date of February 15, 2005.

It is hereby directed that this application be withdrawn from issue at the request of the applicant.

Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of February 15, 2005:

"All reference to Patent No. 6,855,644 to YOICHI SUZUKI, ET AL. of JAPAN for METHOD OF FORMING FILM, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND FILM FORMING APPARATUS appearing in the Official Gazette of February 15, 2005, should be deleted since no patent was granted.

Sherry D. Brinkley

Petitions Examiner Office of Petitions

Office of the Deputy Commissioner for Patent Examination Policy

cc:

Paul Harrison, Crystal Park 3-44I (FAX-306-2737) Deneise Boyd, Crystal Park 2, Suite 1100 (FAX-308-5413)
Mary Louise McAskill, Crystal Park 3-910 (FAX 305-4372)
Niomi Farmer, Crystal Park 3-910 (FAX-305-4372)
Mary E. Johnson (Cookie), P/OCS, CM1-6D07
Duane K.Davis, P/OCS, CM1-6A07
Tamara K. Greene, PK3-910